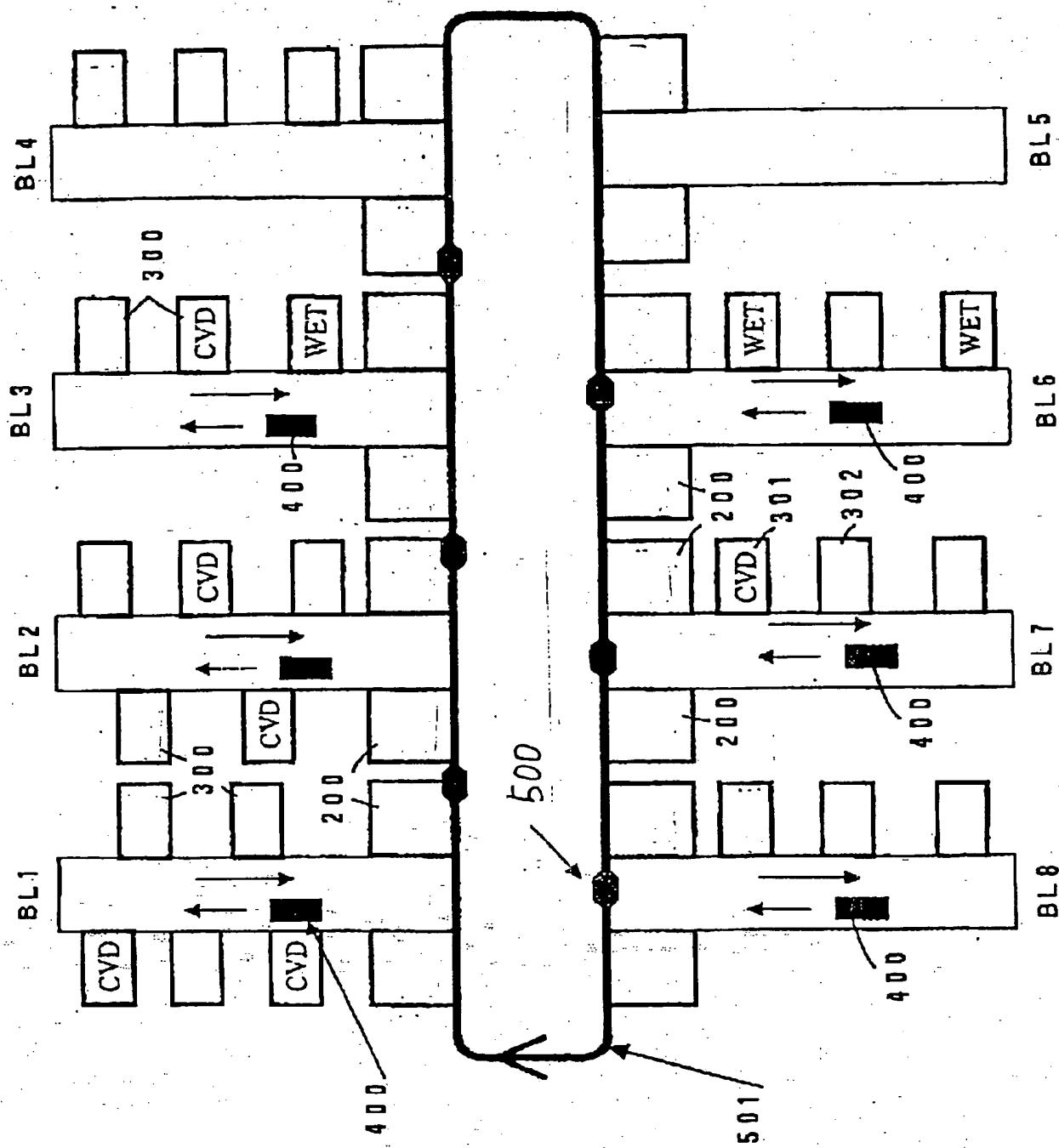


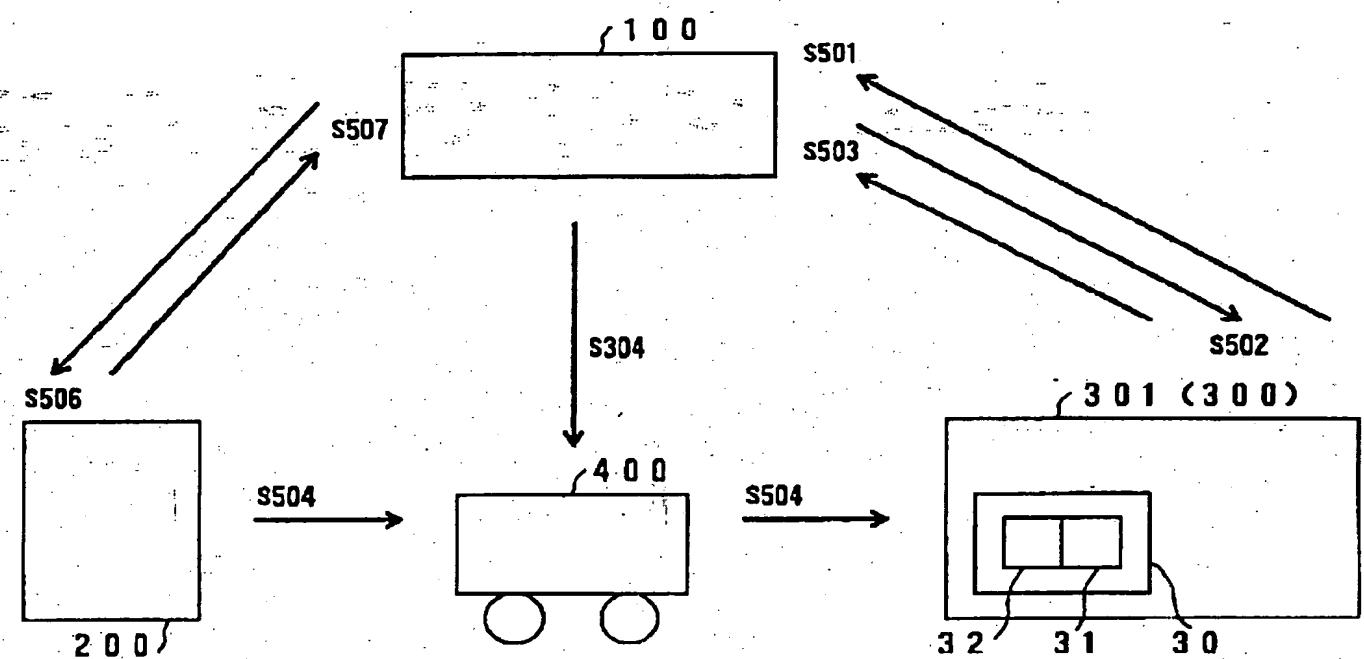
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FIG. 1 prior art



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## FIG. 2 prior art



# FIG. 3

low pressure CVD system

host computer

timer set  
time period

request for loading wafer lots (S501)

notice of the lots to be processed (S502)  
(Lot ID: A, B, C)

request for loading wafer lots (A, B) (S503)

instruct to output and carry lots (A, B) (S504)

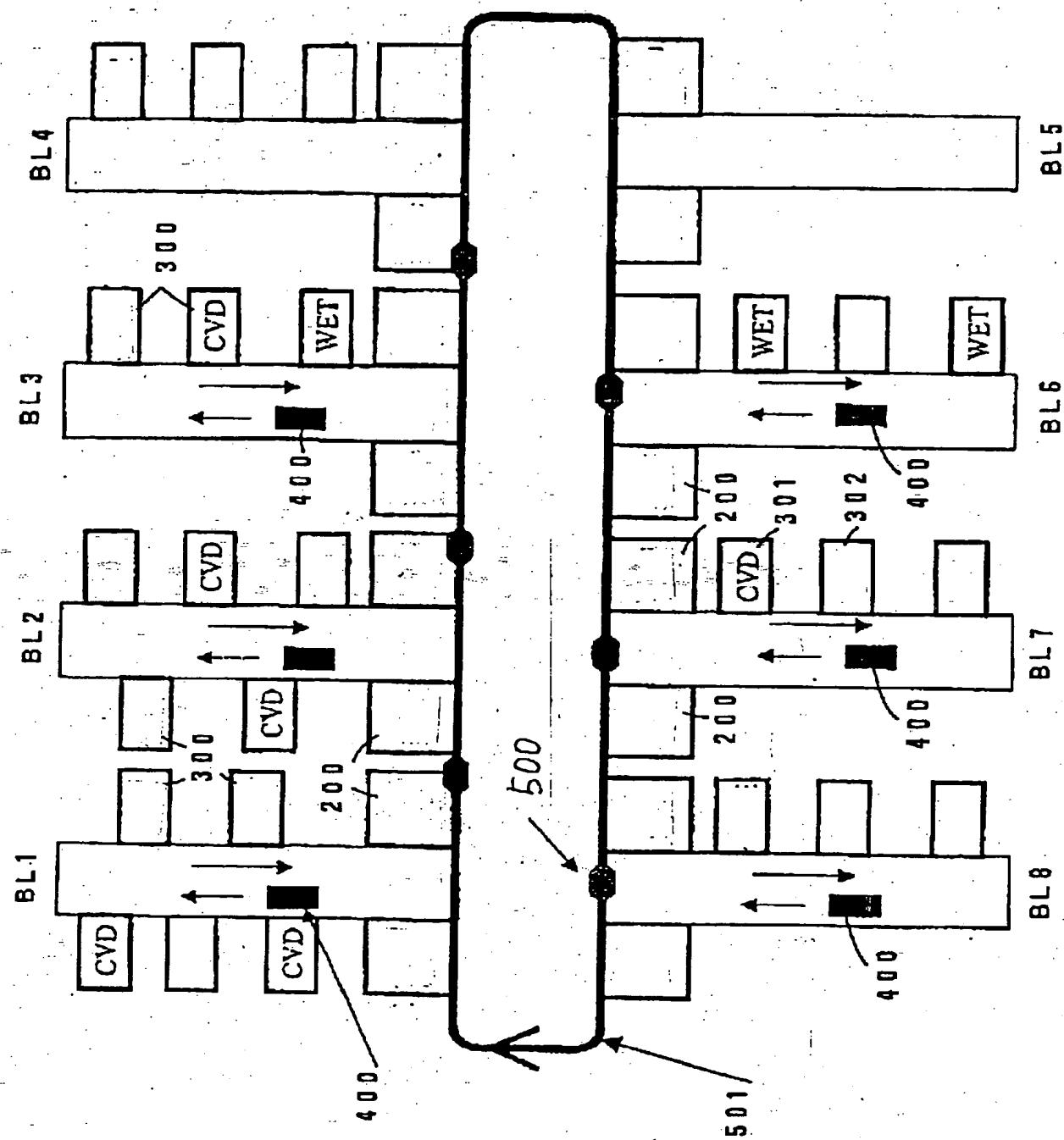
request for loading wafer lot (C) (S505)

instruct to output and carry lot (C) (S504, S506)

request for inhibiting the load (S505)

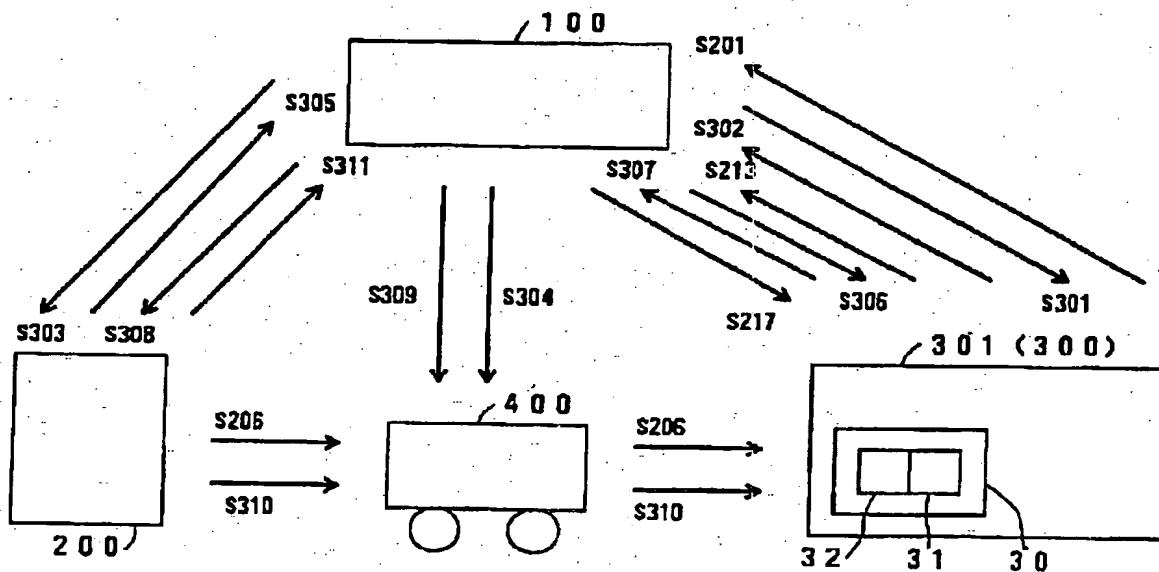
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FIG. 4



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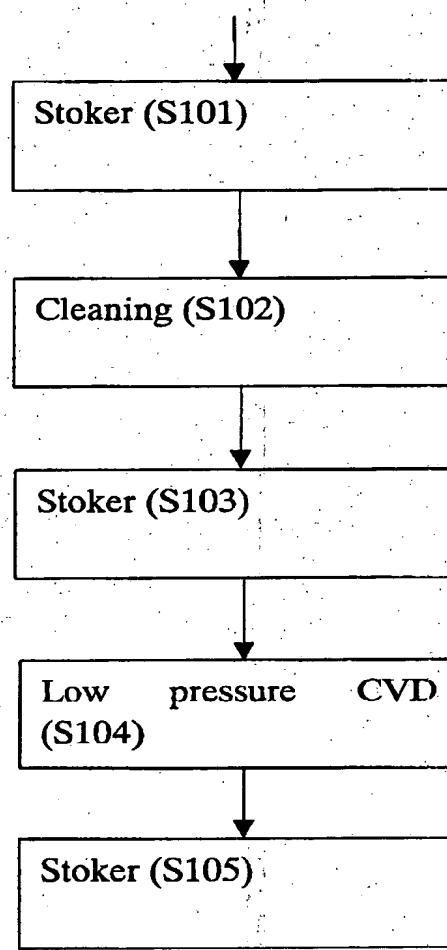
FIG. 5



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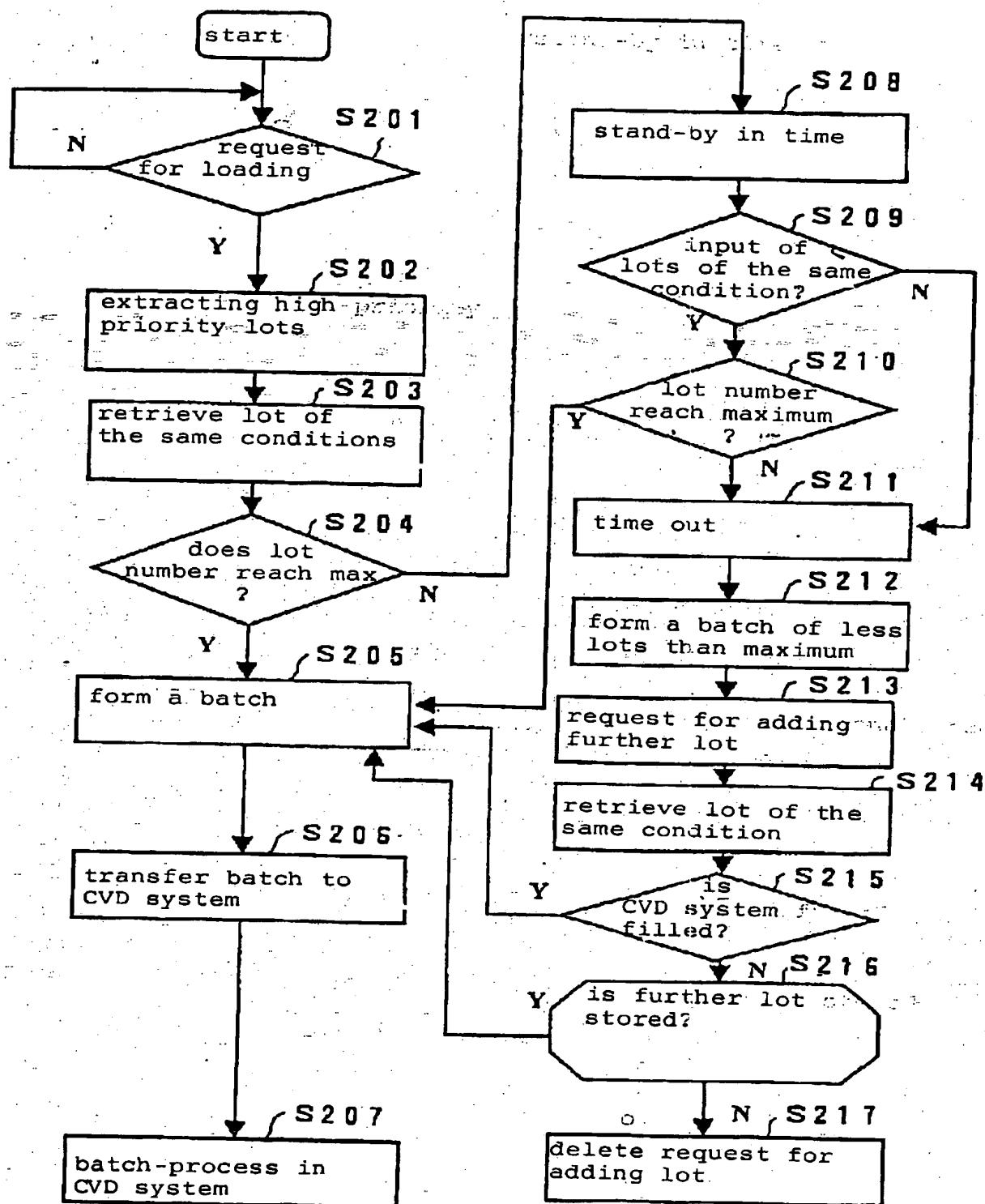
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FIG. 6



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FIG. 7

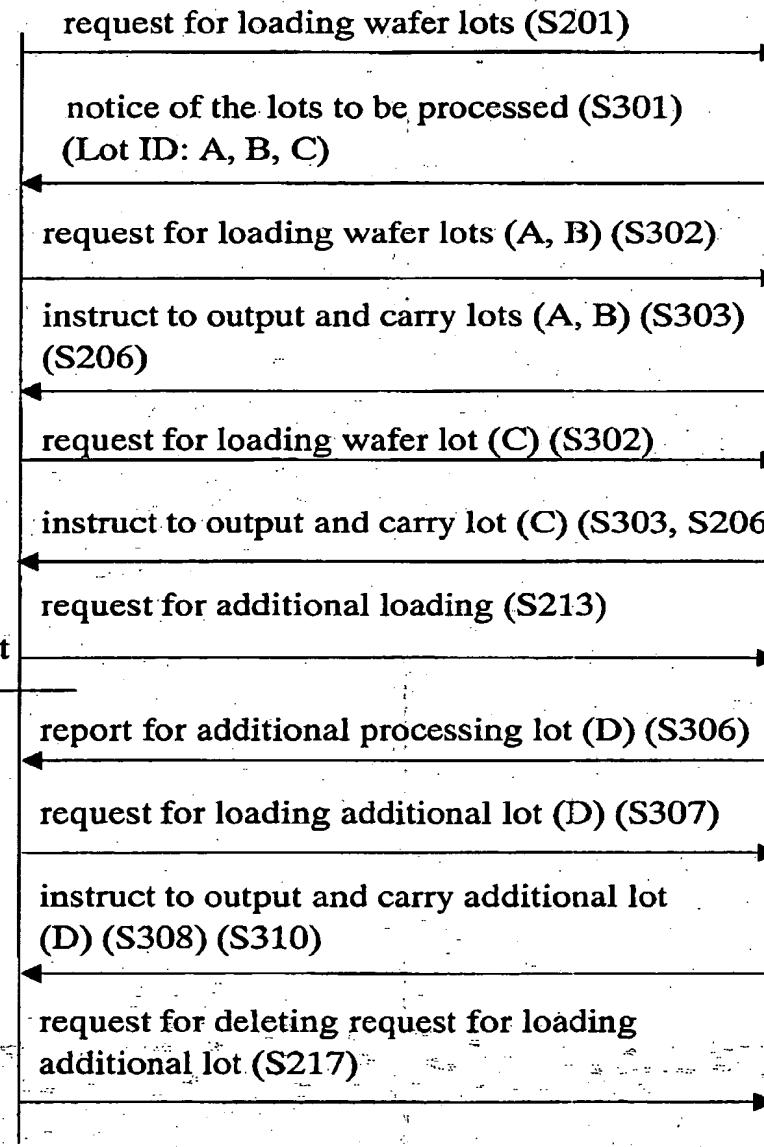


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## FIG. 8

low pressure CVD system

host computer

timer set  
time periodstore new lot  
in stoker

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## FIG. 9

